

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor..... Luan C. Tran
Assignee..... Micron Technology, Inc.
priority Group Art Unit 2812
priority Examiner Kennedy, Jennifer J.
Attorney's Docket No. MI22-2357
Title: Methods of Forming Semiconductor Constructions

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS